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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YOICHI ANDO ET AL.

Application No.: 09/722,454

Filed: November 28, 2000

For: METHOD FOR MANUFACTURING )  
ELECTRON BEAM DEVICE, )  
METHOD FOR MANUFACTURING )  
IMAGE FORMING APPARATUS, )  
ELECTRON BEAM DEVICE AND )  
IMAGE FORMING APPARATUS )  
MANUFACTURED THOSE )  
MANUFACTURING METHODS, )  
METHOD AND APPARATUS FOR )  
MANUFACTURING ELECTRON )  
SOURCE, AND APPARATUS FOR )  
MANUFACTURING IMAGE )  
FORMING APPARATUS )

Examiner: M. Santiago

Group Art Unit: 2879

May 13, 2004

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

LETTER TRANSMITTING CORRECTED DRAWINGS

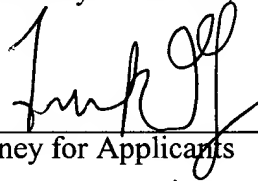
Sir:

Transmitted herewith are nine (9) sheets of formal drawings to be substituted for the corresponding drawing sheets presently on file in the above-identified application.

The new drawing sheets formalize and incorporate the changes made in the Request for Approval To Make Drawing Changes dated February 9, 2004.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,



Attorney for Applicants

Registration No. 42,476

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